

<b>Search Notes</b> 	<b>Application/Control No.</b>	<b>Applicant(s)/Patent under Reexamination</b>	
	10/803,696	KIM, MIN-HO	
	<b>Examiner</b>	<b>Art Unit</b>	
	Paulos M. Natnael	2622	

**SEARCHED**

INTERFERENCE SEARCHED			
Class	Subclass	Date	Examiner